


Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 10559-918001	Application No. 10/799,435
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Alexander Tregub et al.	
		Filing Date March 12, 2004	Group Art Unit 1762 1773

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

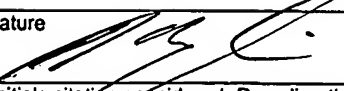
Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
REZ	AQ	K.R. Walton, "The Lubrication of Gold Surfaces by Plasma-Deposited Thin Films of Fluorocarbon Polymer," IEE Transactions on Components, Hybrids, and Manufacturing Technology, v. CHMT-no. 2, 1980
REZ	AR	Karis et al., "Characterization of a Solid Fluorocarbon Film on Magnetic Recording Media," J.Vac. Technol., A 15(4), 1997
REZ	AS	Karis et al., "Tribology of a Solid Fluorocarbon Film on Magnetic Recording Media," IEEE Transaction on Magnetics, V. 34, No. 4, 1998
REZ	AT	Theirich et al., "A Novel Technique for High rate Plasma Polymerization with Radio Frequency Plasmas," Surface and Coating Technology 86-87, 1996

Examiner Signature 	Date Considered 3/31/06
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
RET	AU	P. Singer, "Atomic Layer Deposition Targets Thin Films," Semiconductor International, September 1, 1999
RET	AV	Mark LaPedus "Nikon Evaluating 157-nm Lithography Options," Semiconductor Business News, 5/23/2003
RET	AW	Resrick & Bucks, "Teflon AF Amorphous Fluoropolymers." Chapter 22 in Modern Fluoropolymers, Edited by J. Schews, Jon Wiley & Sons, 1997
RET	AX	Sugiyama, "Perfluoropolymers Obtained by Cyclopolymerization and Their Applications," Chapter 28 in Modern Fluoropolymers, Edited by J. Schews, Jon Wiley & Sons, 1997
RET	AY	Seki et al., Phys. Scripta 41:167(1990))

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